

Author	Review article	Citations	Journal	Year published	DOI or weblink
Leskela, Markku; Ritala, Mikko	Atomic layer deposition (ALD): from precursors to thin film structures	893	Thin Solid Films	2002	https://doi.org/10.1016/S0040-6090(02)00117-7
Leskela, M; Ritala, M	Atomic layer deposition chemistry: Recent developments and future challenges	814	Angew. Chem.-Int. Edit.	2003	https://doi.org/10.1002/anie.200301652
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Wallace, Robert M.; McIntyre, Paul C.; Kim, Jiyoung; Nishi, Yoshio	Atomic Layer Deposition of Dielectrics on Ge and III-V Materials for Ultrahigh Performance Transistors	96	MRS Bull.	2009	https://doi.org/10.1557/mrs2009.137
George, Steven M.	Atomic Layer Deposition: An Overview	3717	Chem. Rev.	2010	https://doi.org/10.1021/cr900056b
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Zhao, Chao; Xiang, Jinjuan	Atomic Layer Deposition (ALD) of Metal Gates for CMOS	9	Appl. Sci.	2019	https://doi.org/10.3390/app9112388
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